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PATENT  
81839.0142

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Eiichi IINO, et al.

Serial No: 10/695,609

Filed: October 28, 2003

For: SILICON SEED CRYSTAL AND  
METHOD FOR PRODUCING  
SILICON SINGLE CRYSTAL

Art Unit: 1722

Examiner: M. A. Anderson

PETITION FOR EXTENSION OF TIMEMail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

I hereby certify that this paper and every paper  
referred to herein is being transmitted via facsimile  
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John P. Scherlacher 08/25/06

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Date

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a two-month extension of time extending to September 19, 2006, the period for response to the Advisory Action dated August 2, 2006. Please charge the fee of \$450 for this extension to Deposit Account No. 50-1314. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN &amp; HARTSON L.L.P.

Date: August 25, 2006

By:

John P. Scherlacher

Registration No. 23,009

Attorney for Applicant(s)

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